



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 98,162-B)

PATENT

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TC 1700

In re Application of:

De Gendt, *et al.*

Serial No.: 09/207,546

Filed: December 8, 1998

For: Method for Removing Organic
Contaminants From A
Semiconductor Surface

Examiner: Ahmed

Group Art Unit: 1746

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231-9999

Dear Sir:

Pursuant to the duty of disclosure provided by 35 C.F.R. § 1.56 and §§ 1.97-98, the applicants wish to make the following references of record in the above-identified application. Copies of the references are enclosed. These references are also listed in the PTO-1449 form enclosed herewith. It is requested that the documents be given careful consideration and that they be cited of record in the prosecution history of the present application so that they will appear on the face of the patent issuing from the present application.

Portions of the references may be material to the examination of the pending claims, however no such admission is intended. 37 C.F.R. 1.97 (h). The references have not been reviewed in sufficient detail to make any other representation and, in particular, no representation is intended as to the relative importance of any portion of the

references. This Statement is not a representation that the cited references have effective dates early enough to be "prior art" within the meaning of 35 U.S.C. sections 102 or 103.

CITED REFERENCES

U.S. Patent Documents

<u>Document</u> <u>Number</u>	<u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Filing Date</u> <u>If appropriate</u>
5,378,317	01/03/95	Kashiwase et al.		

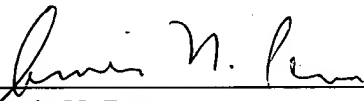
Foreign Patent Documents

<u>Document</u> <u>Number</u>	<u>Date</u>	<u>Country</u>
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Other Documents

Respectfully submitted,
McDonnell Boehnen Hulbert & Berghoff

Date: November 1, 2002

By: 
Amir N. Penn
Registration No. 40,767